

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/734,769	LEE, GEUN JU
	Examiner	Art Unit
	Jack Chiang	2642

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
379	433.13	9/14/2005	X
455	575.3		
See EAST Interference			